

INTERNATIONAL ELECTROTECHNICAL COMMISSION IEC Certification Scheme for Explosive Atmospheres

for rules and details of the IECEx Scheme visit www.iecex.com

Certificate No.: IECEx CML 16.0105X

Issue No: 1 Certificate history:

Status: Current

Issue No. 1 (2017-09-04) Issue No. 0 (2016-11-11)

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Date of Issue: 2017-09-04

Applicant: Pulsar Process Measurement Ltd.

Cardinal Building

Enigma Commercial Centre

Sandy's Road Malvern WR14 1JJ **United Kingdom**

Equipment: MicroFlow-i and Microflow-T

Optional accessory:

Type of Protection: Intrinsic safety

Marking:

Ex ia IIC T4 Ga

Ex ia IIIC T135°C Da

Microflow-i: T_{amb} -20°C to +60°C

Microflow-T: T_{amb} -30°C to +60°C

Approved for issue on behalf of the IECEx

Certification Body:

A Snowdon

Position:

Certification Officer

Signature:

Date:

(for printed version)

September 4, 2017

- 1. This certificate and schedule may only be reproduced in full.
- 2. This certificate is not transferable and remains the property of the issuing body.
- 3. The Status and authenticity of this certificate may be verified by visiting the Official IECEx Website.

Certificate issued by:

Certification Management Limited
Unit 1, Newport Business Park
New Port Road
Ellesmere Port, CH65 4LZ
United Kingdom





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Manufacturer: Pulsar Process Measurement Ltd.

Cardinal Building

Enigma Commercial Centre

Sandy's Road Malvern WR14 1JJ **United Kingdom**

Additional Manufacturing location(s):

This certificate is issued as verification that a sample(s), representative of production, was assessed and tested and found to comply with the IEC Standard list below and that the manufacturer's quality system, relating to the Ex products covered by this certificate, was assessed and found to comply with the IECEx Quality system requirements. This certificate is granted subject to the conditions as set out in IECEx Scheme Rules, IECEx 02 and Operational Documents as amended.

STANDARDS:

The electrical apparatus and any acceptable variations to it specified in the schedule of this certificate and the identified documents, was found to comply with the following standards:

IEC 60079-0 : 2011 Explosive atmospheres - Part 0: General requirements

Edition:6.0

IEC 60079-11 : 2011 Explosive atmospheres - Part 11: Equipment protection by intrinsic safety "i"

Edition:6.0

This Certificate does not indicate compliance with electrical safety and performance requirements other than those expressly included in the

Standards listed above.

TEST & ASSESSMENT REPORTS:

A sample(s) of the equipment listed has successfully met the examination and test requirements as recorded in

Test Report:

GB/CML/ExTR16.0143/00 GB/CML/ExTR17.0151/00

Quality Assessment Report:

GB/SIR/QAR06.0030/07



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Schedule

EQUIPMENT:

Equipment and systems covered by this certificate are as follows:

MicroFlow-i and Microflow-T radar flow sensors

See Annex for full description.

SPECIFIC CONDITIONS OF USE: YES as shown below:

See Annex for specific conditions of use/special conditions for safe use.



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DETAILS OF CERTIFICATE CHANGES (for issues 1 and above):

Issue 1

This variation introduces the following modifications:

- 1. Changes to the circuit and PCB layout of the power supply board.
- 2. A revised front face arrangement of the MicroFlow-i.
- 3. Addition of a new version, MicroFlow-T, to the certificate.
- 4. The addition of a further "X" condition to consider the integral cable parameters.

Annex:

IECEx CML 16.0105X Annex Issue 1.pdf

Annexe to: IECEx CML 16.0105X Issue 1

Applicant: Pulsar Process Measurement Ltd.

Apparatus: MicroFlow-i and MicroFlow-T



Product Description

MicroFlow-i

The MicroFlow-i is a two wire loop powered process flow measurement sensor utilising radar technology. The sensor is housed in a non-metallic enclosure with integral cable which connects to control equipment located in the safe area. The equipment can be operated in either 4-20 mA loop powered mode or digital HART mode. The enclosure incorporates a threaded cap which allows the equipment to be mounted on a suitable bracket.

Intrinsic safety is achieved by connecting to the non-hazardous area via an intrinsically safe interface device, and by encapsulation of the electronics and sensor.

The equipment has the following safety description:

Ui = 28 V

li = 162 mA

Pi = 1.03 W

Ci = 0

Li = 0

MicroFlow-T

The MicroFlow-T is a DC powered process flow measurement sensor utilising radar technology. The sensor is housed in a non-metallic enclosure with integral five core cable which connects to control equipment located in the safe area providing power and data communication. The enclosure incorporates a threaded cap which allows the equipment to be mounted on a suitable bracket.

Intrinsic safety is achieved by connecting to the non-hazardous area via an intrinsically safe interface device, and by encapsulation of the electronics and sensor.

The equipment has the following safety description:

Ui = 9.6V

li = 350 mA

Pi = 0.65 W

Ci = 0

Li = 0











Conditions of manufacture

None

Conditions of Certification/Special Conditions for Safe Use

- i. Under certain extreme circumstances, the non-metallic parts incorporated in the enclosure of this equipment may generate an ignition-capable level of electrostatic charge. Therefore, the equipment shall not be installed in a location where the external conditions are conducive to the build-up of electrostatic charge on such surfaces. This is particularly important if the equipment is installed in a zone 0 location. In addition, the equipment shall only be cleaned with a damp cloth.
- ii. The equipment shall be routinely inspected to avoid the build-up of dust layers when installed in a Zones 20, 21, or 22.
- iii. When installing the equipment, the installer shall consider the length of integral cable attached to the equipment, in addition to any externally installed cable. The integral cable shall be considered to have parameters of 200pF/m, and $1\mu H/m$ or $30\mu H/\Omega$